



3723

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jeong

Serial No.: 09/839,508

Filed: 04/20/01

Title: APPARATUS AND METHOD FOR
SEQUENTIALLY POLISHING AND
LOADING/UNLOADING
SEMICONDUCTOR WAFERS

Group Art Unit: 3723

Examiner: Unknown

Attorney Docket No.: ORL-003

Commissioner for Patents
Washington, D.C. 20231

#5

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TECHNOLOGY CENTER R3700INFORMATION DISCLOSURE STATEMENT

Dear Sir:

This Information Disclosure Statement is submitted:

- ☒ under 37 CFR 1.97(b), or
(Within three months of filing national application; or date of entry of international application; or before mailing date of first office action on the merits; whichever occurs last)
- ☐ under 37 CFR 1.97(c) together with either a:
☐ Statement under 37 CFR 1.97(e), or
☐ a \$180.00 fee under 37 CFR 1.17(p), or
(After the CFR 1.97(b) time period, but before final action or notice of allowance, whichever occurs first)
- ☐ under 37 CFR 1.97(d) together with a:
☐ Statement under 37 CFR 1.97(e), and
☐ a petition under 37 CFR 1.97(d)(2)(ii), and
☐ a \$130.00 petition fee set forth in 37 CFR 1.17(i).
(Filed after final action or notice of allowance, whichever occurs first, but before payment of the issue fee)

☒ Applicant(s) submit herewith Form PTO 1449-Information Disclosure Citation together with copies, of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.



The relevance of the attached references is that this is the closest art of which Applicant is aware. Applicant submits that the above references taken alone or in combination neither anticipate nor render obvious the present invention. Consideration of the foregoing in relation to this application is respectfully requested.

It is requested that the information disclosed herein be made of record in this application.

Respectfully submitted,

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231.

Date of Deposit: 7/19/01

Typed Name: Thomas H. Ham

Signature: Thomas H. Ham

Thomas H. Ham
Attorney/Agent for Applicant(s)
Reg. No. 43,654

Date: July 19, 2001

Telephone No.: 925-249-1300

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 DISCLOSURE
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet

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of

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| | |
|-----------------------------|------------|
| Application Number | 09/839,508 |
| Filing Date | 04/20/2001 |
| First Named Inventor | Jeong |
| Group Art Unit | 3723 |
| Examiner Name | |
| Attorney Docket Number | ORL-003 |

[illegible][illegible]

**Examiner
Signature**

Date
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.
Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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